Form Number(s): None.

Type of Review: Regular submission (Reinstatement).

Affected Public: Individuals or households.

Estimated Number of Respondents: 54,000.

Estimated Time per Response: 90 seconds.

Estimated Total Annual Burden Hours: 1,350 hours.

Estimated Total Annual Cost to Public: \$0.

IV. Requests for Comments

Comments are invited on: (a) Whether the proposed collection of information is necessary for the proper performance of the functions of the agency, including whether the information shall have practical utility; (b) the accuracy of the agency's estimate of the burden (including hours and cost) of the proposed collection of information; (c) ways to enhance the quality, utility, and clarity of the information to be collected; and (d) ways to minimize the burden of the collection of information on respondents, including through the use of automated collection techniques or other forms of information technology.

Comments submitted in response to this notice will be summarized and/or included in the request for OMB approval of this information collection; they also will be a matter of public record.

Dated: May 19, 2010.

Gwellnar Banks,

Management Analyst, Office of the Chief Information Officer.

[FR Doc. 2010–12350 Filed 5–21–10; 8:45 am] BILLING CODE 3510–60–P

DEPARTMENT OF COMMERCE

International Trade Administration

Liquid Crystal Institute, et al., Notice of Consolidated Decision on Applications for Duty–Free Entry of Electron Microscopes

This is a decision consolidated pursuant to Section 6(c) of the Educational, Scientific, and Cultural Materials Importation Act of 1966 (Pub. L. 89– 651, as amended by Pub. L. 106–36; 80 Stat. 897; 15 CFR part 301). Related records can be viewed between 8:30 A.M. and 5:00 P.M. in Room 3720, U.S. Department of Commerce, 14th and Constitution Avenue., NW, Washington, D.C.

Docket Number: 10–005. Applicant: Liquid Crystal Institute, Kent, OH 44242. Instrument: Electron Microscope. Manufacturer: FEI Company, the Czech Republic. Intended Use: See notice at 75 FR 21232, April 23, 2010. *Docket Number: 10–006*. Applicant: Purdue University, West Lafayette, IN 21232, April 23, 2010. Instrument: Electron Microscope. Manufacturer: FEI Corporation, the Netherlands. Intended Use: See notice at 75 FR 21232, April 23, 2010. *Docket Number: 10–007*. Applicant:

Washington University in St. Louis, St. Louis, MO 63130. Instrument: Electron Microscope. Manufacturer: JEOL, Ltd., Japan. Intended Use: See notice at 78 FR 21232, April 23, 2010. Comments: None received. Decision: Approved. No instrument of equivalent scientific value to the foreign instrument, for such purposes as these instruments are intended to be used, was being manufactured in the United States at the time the instruments were ordered. Reasons: Each foreign instrument is an electron microscope and is intended for research or scientific educational uses requiring an electron microscope. We know of no electron microscope, or any other instrument suited to these purposes, which was being manufactured in the United States at the time of order of each instrument.

Dated: May 17, 2010.

Christopher Cassel,

Director, Subsidies Enforcement Office, Import Administration. [FR Doc. 2010–12427 Filed 5–21–10; 8:45 am] BILLING CODE 3510–DS–S

DEPARTMENT OF COMMERCE

United States Patent and Trademark Office

[Docket No. PTO-C-2010-0045]

Extension of Period for Nominations to the National Medal of Technology and Innovation Nomination Evaluation Committee

AGENCY: United States Patent and Trademark Office, Commerce. **ACTION:** Notice and request for nominations.

SUMMARY: The Department of Commerce (United States Patent and Trademark Office) previously published a notice in the **Federal Register** requesting nominations of individuals to serve on the National Medal of Technology and Innovation Nomination Evaluation Committee. The USPTO is extending the deadline until August 1, 2010. The United States Patent and Trademark Office will consider nominations received in response to the original notice as published on February 1, 2010, as well as from this notice of extension and from other sources. The **SUPPLEMENTARY INFORMATION** section of this notice provides committee and membership criteria.

DATES: Please submit nominations by August 1, 2010.

ADDRESSES: Nominations should be submitted to Richard Maulsby, Program Manager, National Medal of Technology and Innovation Program, United States Patent and Trademark Office, P.O. Box 1450, Alexandria, Virginia 22313–1450. Nominations also may be submitted via fax: (571) 270–9100 or by electronic mail to: nmti@uspto.gov.

FOR FURTHER INFORMATION CONTACT:

Richard Maulsby, Program Manager, National Medal of Technology and Innovation Program, United States Patent and Trademark Office, P.O. Box 1450, Alexandria, Virginia 22313–1450, telephone (571) 272–8333, or electronic mail: *nmti@uspto.gov.*

SUPPLEMENTARY INFORMATION:

Background: The committee was established in accordance with the Federal Advisory Committee Act (FACA) (Title 5, United States Code, Appendix 2). The following provides information about the committee and membership:

• Committee members are appointed by and serve at the discretion of the Secretary of Commerce. The committee provides advice to the Secretary on the implementation of Public Law 96–480 (15 U.S.C. 3711), as amended August 9, 2007.

• The committee functions solely as an advisory body under the FACA. Members are appointed to the 12member committee for a term of three years. Each will be reevaluated at the conclusion of the three-year term with the prospect of renewal, pending advisory committee needs and the Secretary's concurrence. Selection of membership is made in accordance with applicable Department of Commerce guidelines.

• Members are responsible for reviewing nominations and making recommendations for the Nation's highest honor for technological innovation, awarded annually by the President of the United States. Members of the committee must have an understanding of, and experience in, developing and utilizing technological innovation and/or be familiar with the education, training, employment and management of technological manpower.

• Under the FACA, membership on a committee must be balanced. To achieve balance, the Department is seeking additional nominations of candidates